



*IFW*  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

JAN RAEBIGER  
HEIKO WAGNER  
UWE SCHULZE  
ROLF SELTMANN

Examiner: Alan A. Mathews

Group Art Unit: 2851

Serial No.: 10/625,451

Att'y Docket: 2000.108200/DE0353

Filed: July 23, 2003

Customer No.: 23720

For: METHOD AND SYSTEM FOR  
IMPROVING EXPOSURE  
UNIFORMITY IN A STEP AND  
REPEAT PROCESS

**RESPONSE TO OFFICE ACTION DATED DECEMBER 27, 2004**

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:	
April 26, 2005 Date	<i>May Paul</i> Signature

This paper is submitted in response to the Office Action dated December 27, 2004, for which the three-month date for response was March 27, 2005. A request for a one-month extension of time to respond is included herewith. This one-month extension will bring the due date to April 27, 2005, which is within the six-month statutory period.

A fee in the amount of \$120 is believed to be due in connection with the present response. **The Director is authorized to deduct such fee, and any other fees required under 37 C.F.R. §§ 1.16 to 1.21, from Advanced Micro Devices, Inc. Deposit Account No. 01-0365/DE0353.** In the event the monies in that account are insufficient, the Director is

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authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.108200.

Reconsideration of the application in view of the following amendments and remarks is respectfully requested.